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Substitute for form 1449/PTO								
				Application Number	10/596,736-Conf. #9973			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Filing Date	June 22, 2006			
				First Named Inventor	Frank Fiedler	7		
				Art Unit	N/A			
				Examiner Name	Not Yet Assigned /Sunray R.	C hang/ (09/15/20		
Sheet	1	of	1	Attorney Docket Number	20793/0204864-US0			

U.S. PATENT DOCUMENTS					
Examiner	Cite	Document Number	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where
Initials*	No.1	Number-Kind Code ² (if known)	MM-DD-YYYY	Applicant of Cited Document	Relevant Passages or Relevant Figures Appear
	AA*	US-5,703,714	12-30-1997	Kojima et al.	<u>,</u>
	AB*	US-6,133,561	10-17-2000	Toshimitsu et al.	
	AC*	US-5,499,097	03-12-1996	Ortyn et al.	·
	AD*	US-5,260,825	11-09-1993	Nagano et al.	
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FOREIGN PATENT DOCUMENTS						
Examiner	Cite No.1	Foreign Patent Document	Publication	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
Initials*		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	Date MM-DD-YYYY			
	ВА	WO-96/18924	06-20-1996	Olympus Optical Co. et al.		
	BB	EP-1 445 635	08-11-2004	Leica Microsystems et al.		
	вс	DE-19839777	03-11-1999	Nippon Kogaku Kk		1

*EXAMINER: initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. * CITE NO.: Those application(s) which are marked with an single asterisk (*) next to the Cite No. are not supplied (under 37 CFR 1.96(a)(2)(iii)) because that application was filed after June 30, 2003 or is available in the IFW. 'Applicant's unique citation designation number (optional). * See Kinds Codes of USPTO Petent Documents at www.uspto.gov or MPEP 801.04. * Enter Office that issue the document, by the two-letter code (WIPO Standard ST.3). * For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. * Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. * Applicant is to place a check mark here if English language Translation is attached.

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Examiner	/Sunray R. Chang/ (09/15/2008)	Date
Signature	3 (**** ****)	Considered

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